



KNF LABORATORY  
EQUIPMENT  
KNOWING  
WHAT COUNTS



# KNF LABORATORY EQUIPMENT

## COMPELLING ADVANTAGES

**KNF is dedicated to** countering the challenges of daily lab routines. Our products offer clear advantages: unparalleled performance, ease of use, quiet and intuitive operation, small footprint, and utmost reliability.

**Discover lab technology that supports you.**



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# LABOPORT® REDESIGNED

UNIQUE DESIGN,  
EASE OF USE

HELLO,  
NEW  
LABOPORT!



LABOPORT® N 96



LABOPORT® N 840 G

LABOPORT® N 820 G

# HELLO, NEW LABOPORT SYSTEMS!



## ■ Exceptionally small footprint

This impressively compact pump provides the user with increased bench space.

## ■ Easy to clean

The smooth surfaces without any ribs or hard edges are easy to keep clean.

## ■ Chemically resistant

All wetted materials are suited for use with aggressive/corrosive gases.

## ■ Expandable

Separators and/or condensers can be purchased individually at any time and easily fitted, enabling users to build their own customized vacuum system.

## ■ Integrated gas ballast valve

The valve protects the pump head and shortens processing times – even with high boiling point solvents.

## ■ Portable

The fold-out handle makes the device easy to transport and store.

## ■ Speed-controlled

Manually adjust the pump speed via the control knob or automatically by connecting to KNF's VC 900 vacuum controller.

## ■ 3-color status display

The changing color display allows the operational status to be ascertained at a glance.





# ROTARY EVAPORATION/ DISTILLATION

REPRODUCIBLE RESULTS WITH SHORT  
PROCESSING TIMES



DESIGNED FOR EVERY DAY USE

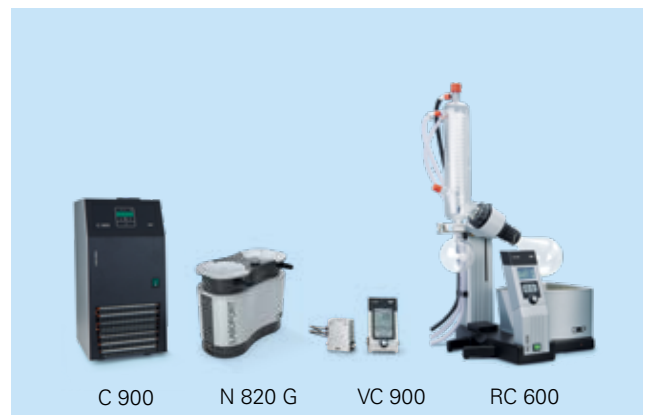
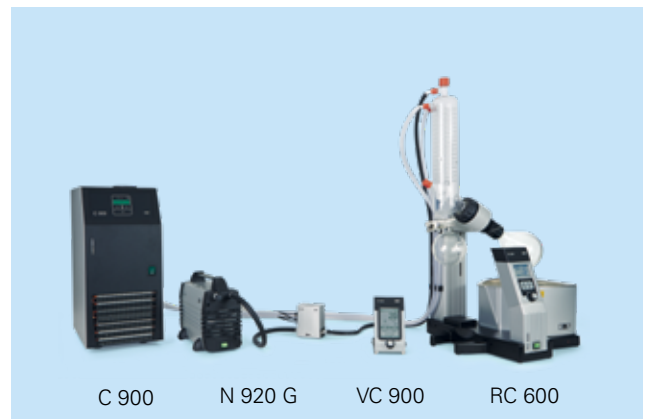
**RC 600 Rotary Evaporator**



- Electric lift for automatic raising and lowering of the evaporation flask
- Central control of all relevant distillation parameters, including rotation speed, bath temperature, and flask depth
- Memory function saves the flask's current immersion depth and rotation speed for easy and reliable process reliability
- Cordless heating bath with heat-indicating diode and integrated pour spout for safe, spill-free emptying
- Convenient, fully adjustable flask angle set via a control knob
- Uncomplicated flask exchange — flask simply locks in place — and can be done with one hand
- Efficient, easy-to-clean recirculating condenser and seal attach with secure clamping nut. A dry ice condenser is also available in place of the recirculating condenser.
- External tube guide keeps the benchtop tidy and safe

**A VERSATILE SYSTEM COMPONENT**

**Set for flexibility:** Several system packages to suit different budget conditions are available. The VC 900 vacuum control unit can also be used to precisely control vacuum pumps from other manufacturers.





SC 920 G

## ADAPTIVE CONTROL

### SC 920 G Vacuum Pump System

- Vacuum system comprised of chemically resistant diaphragm vacuum pump, vacuum controller, inlet separator, and outlet condenser
- Adjustable flow rate up to 21 l/min, 1.5 torr ultimate vacuum
- Quiet operation
- Automatic, accurate recognition and monitoring of the boiling point
- High recovery rates even with low boiling point solvents
- PPS pump heads combined with PTFE-coated diaphragms are ideal for aggressive/corrosive gases and vapors
- Integrated gas ballast
- Speed-controlled

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## LABOPORT®



SH 820 G

## SOLVENT RECOVERY

### SH 820 G and SH 840 G Vacuum Pump System

- Vacuum system comprised of chemically resistant diaphragm vacuum pump, base plate, inlet separator, and outlet condenser
- SH 820 G manually adjustable flow rate up to 20 l/min, 4.5 torr ultimate vacuum
- SH 840 G manually adjustable flow rate up to 34 l/min, 4.5 torr ultimate vacuum
- Integrated gas ballast

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## POSSIBLE CONNECTIONS

Connect the VC 900 Vacuum Controller to control the pump speed/vacuum process of N 920 G, N 820 G, N 840 G vacuum pumps and SH 820 G, SH 840 G vacuum systems. Featuring 4 different operating modes, the VC 900 provides automatic, accurate recognition and monitoring of the boiling point.





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N 820 G

N 840 G

**CHEMICALLY RESISTANT**
**N 820 G and N 840 G Diaphragm Vacuum Pumps**

- N 820 G flow rate up to 20 l/min, 4.5 torr ultimate vacuum
- N 840 G flow rate up to 34 l/min, 4.5 torr ultimate vacuum
- High level of vapor and condensate compatibility
- Integrated rotational speed control
- PTFE pump heads combined with PTFE-coated diaphragms are ideal for extremely aggressive/corrosive gases and vapors
- Integrated gas ballast valve
- 3-color status display for in operation / stand-by / error
- Expandable: Separators and/or condensers can be purchased individually at any time and easily fitted, enabling users to build their own customized vacuum system

**Tip:** When connected to the VC 900 vacuum controller the pump speed can be optimized for your specific application requirements.

LABOPORT®


**ROBUST**
**UN 842.3 FTP Diaphragm Vacuum Pump**

- Flow rate 34 l/min, 1.5 torr ultimate vacuum
- High level of vapor and condensate compatibility
- PTFE pump heads combined with PTFE-coated diaphragms are ideal for extremely aggressive/corrosive gases and vapors

**SPEED-CONTROLLED**
**N 920 G Diaphragm Vacuum Pump**

- Flow rate up to 21 l/min flow, 1.5 torr ultimate vacuum
- High suction speed, particularly in the low vacuum range
- Integrated rotational speed control
- PPS pump heads combined with PTFE-coated diaphragms are ideal for aggressive/corrosive gases and vapors
- Integrated gas ballast valve

**Tip:** When connected to the VC 900 vacuum controller the pump speed can be optimized for your specific application requirements.





#### HIGH FLOW

##### **N 860.3 FT.40.18 Diaphragm Vacuum Pump**

- Flow rate 60 l/min, 3 torr ultimate vacuum
- Integrated KNF self-drying system ensures that condensate is quickly removed from the pump heads without the vacuum being altered. This significantly reduces process time and protects the pump heads in high-moisture applications.
- Chemically resistant flowpath ideal for use with extremely aggressive/corrosive gases and vapors



#### VACUUM CONTROL

##### **VC 900 Vacuum Control Unit**

- Four operating modes ensure versatility and ease-of-use
- Control of the vacuum application
- Separate control unit with pressure sensors and two-step controlled valve to be placed independently from the operating unit
- Easy to use



#### RECIRCULATING CHILLER

##### **C 900 Chiller**

- Operating temperature range -10 to +40 °C, cooling capacity 250 W
- Compact design, small footprint
- Splash-proof membrane keypad
- Easy to fill





**DEGASSING**  
CONSTANT VACUUM FOR  
CLEAR RESULTS

LABOPORT®



## HIGH-PERFORMANCE

**UN 816.3 KTP**

- Flow rate 16 l/min, 15 torr ultimate vacuum
- PPS pump heads combined with PTFE-coated diaphragms are ideal for aggressive/corrosive gases and vapors
- Optional model (.45) with vacuum gauge and regulator

LABOPORT®



## FAST

**N 938.50 KT.18 Diaphragm Vacuum Pump**

- Flow rate 30 l/min, 11 torr ultimate vacuum
- Connecting both pump heads in parallel and in series ensures exceptionally fast evacuation
- PPS pump heads combined with PTFE-coated diaphragms are ideal for aggressive/corrosive gases and vapors

LABOPORT®



## CHEMICALLY RESISTANT

**N 820 G Diaphragm Vacuum Pump**

- Flow rate up to 20 l/min, 4.5 torr ultimate vacuum
- High level of vapor and condensate compatibility
- Integrated rotational speed control
- PTFE pump heads combined with PTFE-coated diaphragms are ideal for extremely aggressive/corrosive gases and vapors
- Integrated gas ballast valve
- 3-color status display for in operation / stand-by / error
- Expandable: Separators and/or condensers can be purchased individually at any time and easily fitted, enabling users to build their own customized vacuum system

**Tip:** When connected to the VC 900 vacuum controller the pump speed can be optimized for your specific application requirements.

## SPEED-CONTROLLED

**N 920 G Diaphragm Vacuum Pump**

- Flow rate up to 21 l/min, 1.5 torr ultimate vacuum
- High suction speed, particularly in the low vacuum range
- Integrated rotational speed control
- PPS pump heads combined with PTFE-coated diaphragms are ideal for aggressive/corrosive gases and vapors
- Integrated gas ballast valve

**Tip:** When connected to the VC 900 vacuum controller the pump speed can be optimized for your specific application requirements.







# FILTRATION/SPE

RELIABLE VACUUM  
FOR CLEAN RESULTS.  
COMPACT, POWERFUL, FAST.



LABOPORT®



## SMALL AND VERSATILE

**N 96 Mini Diaphragm Vacuum Pump**

- Flow rate up to 7 l/min, 97.5 ultimate vacuum
- Extremely small footprint
- Integrated rotational speed control
- PPS pump head combined with PTFE-coated diaphragm is ideal for aggressive/corrosive gases and vapors

LABOPORT®



UN 811 KVP



UN 816.3 KTP

## HIGH-PERFORMANCE

**UN 811 KVP, UN 816.3 KTP and UN 816.1.2 KTP Diaphragm Vacuum Pumps**

- UN 811 KVP flow rate 13 l/min, 75 torr ultimate vacuum
- UN 816.3 KTP flow rate 16 l/min, 15 torr ultimate vacuum
- UN 816.1.2 KTP flow rate 30 l/min, 120 torr ultimate vacuum
- PPS pump heads combined with PTFE-coated diaphragms are ideal for aggressive/corrosive gases and vapors
- Optional model (.45) with vacuum gauge and regulator

LABOPORT®



## FAST

**N 938.50 KT.18 Diaphragm Vacuum Pump**

- Flow rate 30 l/min, 11 torr ultimate vacuum
- Connecting both pump heads in parallel and in series ensures exceptionally fast evacuation
- PPS pump heads combined with PTFE-coated diaphragms are ideal for aggressive/corrosive gases and vapors

LABOPORT®



## CHEMICALLY RESISTANT

**N 840 G Diaphragm Vacuum Pump**

- Flow rate up to 34 l/min, 4.5 torr ultimate vacuum
- High level of vapor and condensate compatibility
- Integrated rotational speed control
- PTFE pump heads combined with PTFE-coated diaphragms are ideal for extremely aggressive/corrosive gases and vapors
- Integrated gas ballast valve
- 3-color status display for in operation / stand-by / error
- Expandable: Separators and/or condensers can be purchased individually at any time and easily fitted, enabling users to build their own customized vacuum system

**Tip:** When connected to the VC 900 vacuum controller the pump speed can be optimized for your specific application requirements.





# FLUID ASPIRATION

RELIABLE VACUUM WITH PROCESS-SPECIFIC  
FLOW RATES



LABOPORT®



## SMALL AND VERSATILE

**N 96 Mini Diaphragm Vacuum Pump**

- N 96 flow rate up to 7 l/min, 97.5 torr ultimate vacuum
- Extremely small footprint
- Integrated rotational speed control
- PPS pump head combined with PTFE-coated diaphragm is ideal for aggressive/corrosive gases and vapors

**UN 811 KVP Mini Diaphragm Vacuum Pump**

- Flow rate 13 l/min, 75 torr ultimate vacuum
- Small footprint
- PPS pump head combined with PTFE-coated diaphragm is ideal for aggressive/corrosive gases and vapors
- Optional model (.45) with vacuum gauge and regulator

LABOPORT®



## HIGH-PERFORMANCE

**UN 816.3 KTP Diaphragm Vacuum Pump**

- Flow rate 16 l/min, 15 torr ultimate vacuum
- PPS pump heads combined with PTFE-coated diaphragms are ideal for aggressive/corrosive gases and vapors
- Optional model (.45) with vacuum gauge and regulator

LABOPORT®



## FAST

**N 938.50 KT.18 Diaphragm Vacuum Pump**

- Flow rate 30 l/min, 11 torr ultimate vacuum
- Connecting both pump heads in parallel and in series ensures exceptionally fast evacuation
- PPS pump heads combined with PTFE-coated diaphragms are ideal for aggressive/corrosive gases and vapors

LABOPORT®



## CHEMICALLY RESISTANT

**N 820 G Diaphragm Vacuum Pump**

- Flow rate up to 20 l/min, 4.5 torr ultimate vacuum
- High level of vapor and condensate compatibility
- Integrated rotational speed control
- PTFE pump heads combined with PTFE-coated diaphragms are ideal for extremely aggressive/corrosive gases and vapors
- Integrated gas ballast valve
- 3-color status display for in operation / stand-by / error
- Expandable: Separators and/or condensers can be purchased individually at any time and easily fitted, enabling users to build their own customized vacuum system

**Tip:** When connected to the VC 900 vacuum controller the pump speed can be optimized for your specific application requirements.



**METERING AND  
TRANSFERRING LIQUIDS**  
PRECISE, SAFE AND CLEAN HANDLING  
OF NEUTRAL AND AGGRESSIVE LIQUIDS



## LIQUIPORT®



## RELIABLE LIQUID TRANSFER

**NF 100 and NF 300 Chemically-resistant Diaphragm Liquid Pumps**

- NF 100 flow rate from 0.2 to 1.3 l/min; pressure head 15 psig; suction head 9.8 ft. H<sub>2</sub>O
- NF 300 flow rate from 0.5 to 3 l/min; pressure head 15 psig; suction head 9.8 ft. H<sub>2</sub>O
- NF 1.100 & NF 1.300 models pressure head 58 psig
- Self priming, dry running
- Pump heads available in your choice of PP, PVDF or PTFE
- PTFE-coated diaphragms, FFKM valves
- Flow rate can be set manually (S Version) or via an external analog control device (RC Version)

## SIMDOS®



## PRECISE LIQUID METERING

**SIMDOS® 02 and SIMDOS® 10 Chemically-resistant Diaphragm Liquid Pumps**

- SIMDOS 02 flow rate from 0.03 to 20 ml/min; pressure head 85 psig; suction head 6.6 ft. H<sub>2</sub>O
- SIMDOS 10 flow rate from 1 to 100 ml/min; pressure head 85 psig; suction head 9.8 ft. H<sub>2</sub>O
- Self priming, dry running
- Pump heads available in your choice of PP, PVDF, PTFE or Stainless Steel
- PTFE-coated diaphragms\* FFKM valves
- Flow rate and dose volume can be set manually (S Version) or externally by either an analog or RS 232 control device (RCP Version)

\* FFKM diaphragm standard for SIMDOS 02 PTFE head model

# GEL DRYING

OPTIMUM RESULTS ACHIEVED  
THANKS TO CHEMICAL RESISTANCE  
AND FULLY VARIABLE VACUUM



LABOPORT®



## CHEMICALLY RESISTANT

### N 820 G Diaphragm Vacuum Pump

- Flow rate up to 20 l/min, 4.5 torr ultimate vacuum
- High level of vapor and condensate compatibility
- Integrated rotational speed control
- PTFE pump heads combined with PTFE-coated diaphragms are ideal for extremely aggressive/corrosive gases and vapors
- Integrated gas ballast valve
- 3-color status display for in operation / stand-by / error
- Expandable: Separators and/or condensers can be purchased individually at any time and easily fitted, enabling users to build their own customized vacuum system

**Tip:** When connected to the VC 900 vacuum controller the pump speed can be optimized for your specific application requirements.



## SPEED-CONTROLLED

### N 920 G Diaphragm Vacuum Pump

- Flow rate up to 21 l/min, 1.5 torr ultimate vacuum
- High suction speed, particularly in the low vacuum range
- Integrated rotational speed control
- PPS pump heads combined with PTFE-coated diaphragms are ideal for aggressive/corrosive gases and vapors
- Integrated gas ballast valve

**Tip:** When connected to the VC 900 vacuum controller the pump speed can be optimized for your specific application requirements.



# CENTRIFUGAL CONCENTRATION

PRECISE, HIGH-PERFORMANCE  
VACUUM FOR RAPID, GENTLE TREATMENT  
OF SAMPLES





### SPEED-CONTROLLED

#### N 920 G Diaphragm Vacuum Pump

- Flow rate up to 21 l/min, 1.5 torr ultimate vacuum
- High suction speed, particularly in the low vacuum range
- Integrated rotational speed control
- PPS pump heads combined with PTFE-coated diaphragms are ideal for aggressive/corrosive gases and vapors
- Integrated gas ballast valve

**Tip:** When connected to the VC 900 vacuum controller the pump speed can be optimized for your specific application requirements.

LABOPORT®



### CHEMICALLY RESISTANT

#### N 840 G Diaphragm Vacuum Pump

- Flow rate up to 34 l/min, 4.5 torr ultimate vacuum
- High level of vapor and condensate compatibility
- Integrated rotational speed control
- PTFE pump heads combined with PTFE-coated diaphragms are ideal for extremely aggressive/corrosive gases and vapors
- Integrated gas ballast valve
- 3-color status display for in operation / stand-by / error
- Expandable: Separators and/or condensers can be purchased individually at any time and easily fitted, enabling users to build their own customized vacuum system

**Tip:** When connected to the VC 900 vacuum controller the pump speed can be optimized for your specific application requirements.



### HIGH FLOW

#### N 860.3 FT.40.18 Diaphragm Vacuum Pump

- Flow rate 60 l/min, 3 torr ultimate vacuum
- Integrated KNF self-drying system ensures that condensate is quickly removed from the pump heads without the vacuum being altered. This significantly reduces process time and protects the pump heads in high-moisture applications.
- Chemically resistant flowpath ideal for use with extremely aggressive/corrosive gases and vapors





## VACUUM OVEN

OUTSTANDING CHEMICAL AND CONDENSATE  
COMPATIBILITY WITH FAST EVACUATION OF  
LARGE VAPOR QUANTITIES

LABOPORT®



N 820 G

N 840 G

## CHEMICALLY RESISTANT

**N 820 G and N 840 G Diaphragm Vacuum Pumps**

- N 820 G flow rate up to 20 l/min, 4.5 torr ultimate vacuum
- N 840 G flow rate up to 34 l/min, 4.5 torr ultimate vacuum
- High level of vapor and condensate compatibility
- Integrated rotational speed control
- PTFE pump heads combined with PTFE-coated diaphragms are ideal for extremely aggressive/corrosive gases and vapors
- Integrated gas ballast valve
- 3-color status display for in operation / stand-by / error
- Expandable: Separators and/or condensers can be purchased individually at any time and easily fitted, enabling users to build their own customized vacuum system

**Tip:** When connected to the VC 900 vacuum controller the pump speed can be optimized for your specific application requirements.

LABOPORT®



## FOR EXTREMELY WET VAPORS

**UN 820.3 FT.40P and UN 840.3 FT.40P Diaphragm Vacuum Pumps**

- UN 820.3 FT.40P flow rate 20 l/min, 8 torr ultimate vacuum
- UN 840.3 FT.40P flow rate 34 l/min, 8 torr ultimate vacuum
- Integrated KNF self-drying system ensures that condensate is quickly removed from the pump heads without the vacuum being altered. This significantly reduces process time and protects the pump heads in high-moisture applications.
- Chemically resistant flowpath ideal for use with extremely aggressive/corrosive gases and vapors

## HIGH FLOW

**N 860.3 FT.40.18 Diaphragm Vacuum Pump**

- Flow rate 60 l/min, 3 torr ultimate vacuum
- Integrated KNF self-drying system ensures that condensate is quickly removed from the pump heads without the vacuum being altered. This significantly reduces process time and protects the pump heads in high-moisture applications.
- Chemically resistant flowpath ideal for use with extremely aggressive/corrosive gases and vapors



# MULTI-USER VACUUM SYSTEMS

INEXPENSIVE, SPACE-SAVING SOLUTIONS FOR SUPPLYING VACUUM TO DIFFERENT APPLICATIONS





## HIGH FLOW

### N 860.3 FT.40.18 Diaphragm Vacuum Pump

- Flow rate 60 l/min, 3 torr ultimate vacuum
- Integrated KNF self-drying system ensures that condensate is quickly removed from the pump heads without the vacuum being altered. This significantly reduces process time and protects the pump heads in high-moisture applications.
- Chemically resistant flowpath ideal for use with extremely aggressive/corrosive gases and vapors

## LABOBASE®



SBC 860.40

## TWO-POINT CONTROL

### SBC 840.40 and SBC 860.40 Vacuum Systems

- Fully-automated vacuum generation system comprised of chemically resistant diaphragm vacuum pump, base plate, high-performance condenser, separator, vacuum control device, valves and control unit.
- SBC 840.40 for up to 4 users
  - Flow rate 34 l/min, 7.5 torr ultimate vacuum
- SBC 860.40 for up to 10 users
  - Flow rate 60 l/min, 3 torr ultimate vacuum

## VACUUM CONTROL

### VC 900 Vacuum Control Unit

- Connect to any vacuum source
- Control of the vacuum application
- Separate control unit with pressure sensors and two-step controlled valve to be placed independently from the operating unit
- Easy to use





TECHNICAL DATA

	LABOPORT® N 96	LABOPORT® UN 811 KVP	LABOPORT® UN 816.3 KTP	LABOPORT® N 816.1.2 KTP	LABOPORT® N 938.50 KT.18	
<b>APPLICATION</b>	<b>Rotary evaporation</b>					
	<b>Distillation</b>					
	<b>Degassing</b>			x		x
	<b>Filtration</b>	x	x	x	x	x
	<b>SPE</b>	x	x	x		x
	<b>Fluid aspiration</b>	x	x	x		x
	<b>Metering/Transferring liquids</b>					
	<b>Gel drying</b>					
	<b>Centrifugal concentration</b>					
	<b>Vacuum oven</b>					
	<b>Multi-user vacuum systems</b>					
<b>TECHNICAL DATA</b>	<b>Flow rate at atm. pressure – l/min (m³/h)</b>	7 (0.4)	13 (0.78)	16 (0.96)	30 (1.8)	30 (1.8)
	<b>Ultimate vacuum – torr (mbar abs.)</b>	97.5 (130)	75 (100)	15 (20)	120 (160)	11 (15)
	<b>Operating pressure – psig (bar)</b>	36.26 (2.5)	7.4 (0.5)	7.4 (0.5)	7.4 (0.5)	7.4 (0.5)
	<b>Connectors for tube – in.</b>	ID 1/4	ID 1/4	ID 1/4	ID 1/4	ID 3/8
	<b>Permissible media and ambient temperature</b>	5 to 40 °C (41 to 104 °F)	5 to 40 °C (41 to 104 °F)	5 to 40 °C (41 to 104 °F)	5 to 40 °C (41 to 104 °F)	5 to 40 °C (41 to 104 °F)
	<b>Weight - lbs. (kg)</b>	2.9 (1.3)	5.5 (2.5)	8.7 (3.95)	8.7 (3.95)	15.0 (6.8)
	<b>Dimensions W x H x D – in. (mm)</b>	6.1 x 4.7 x 3.0 (156 x 119 x 75)	3.5 x 7.4 x 6.2 (90 x 187 x 157)	3.5 x 5.6 x 14.2 (90 x 141 x 361)	4.0 x 5.6 x 14.2 (102 x 141 x 361)	4.3 x 8.3 x 12.5 (110 x 212 x 317)
<b>MATERIAL</b>	<b>Pump head</b>	PPS	PPS	PPS	PPS	PPS
	<b>Diaphragm</b>	PTFE-coated	PTFE-coated	PTFE-coated	PTFE-coated	PTFE-coated
	<b>Valves</b>	FPM	FFPM	FFPM	FFPM	FFPM
<b>ACCESSORIES</b>	<b>Silencer</b>		Order no. 007005	Order no. 000345		Order no. 007006
	<b>Column fixture</b>	Order no. 323484				
	<b>Fine control valve with vacuum gauge</b>		UN 811 KV.45P	UN 816.3 KT.45P	UN 816.1.2 KT.45P	Order no. 112432
	<b>Connection cable to N 920 G interface</b>					
	<b>Connection cable to N 820 G/N 840 G interface</b>					
	<b>400 ml Dry ice trap</b>	UST 800	UST 800	UST 800	UST 800	UST 800
	<b>500 ml Woulfe bottle</b>	Order no. 057953	Order no. 057953	Order no. 057953	Order no. 057953	Order no. 057953
<b>1000 ml Woulfe bottle</b>	Order no. 057954	Order no. 057954	Order no. 057954	Order no. 057954	Order no. 057954	

	N 920 G	LABOPORT® UN 842.3 FTP	LABOPORT® SD UN 820.3 FT.40P	LABOPORT® SD UN 840.3 FT.40P	N 860.3 FT.40.18	VC 900
	x	x			x	x
	x	x			x	x
	x					
	x					
	x				x	
			x	x	x	
						x
	21 (1.26)	34 (2.04)	20 (1.2)	34 (2.04)	60 (3.6)	
	1.5 (2)	1.5 (2)	8 (10)	8 (10)	3 (4)	
	7.4 (0.5)	14.5 (1)	14.5 (1)	14.5 (1)	14.5 (1)	
	ID 3/8	ID 3/8	ID 3/8	ID 3/8	ID 1/2	pneumatic: ID 3/8 coolants: ID 3/8 inert gas: ID 3/16
	<b>Media temp.:</b> 5 to 40 °C (41 to 104 °F) <b>Ambient temp.:</b> 10 to 40 °C (50 to 104 °F)	5 to 40 °C (41 to 104 °F)	5 to 40 °C (41 to 104 °F)	5 to 40 °C (41 to 104 °F)	5 to 40 °C (41 to 104 °F)	5 to 40 °C (41 to 104 °F)
	18.7 (8.5)	29.5 (13.4)	21.1 (9.6)	28.4 (12.9)	32.6 (14.8)	2.6 (1.2)
	6.2 x 8.9 x 12.8 (158 x 226 x 324)	6.6 x 9.0 x 13.4 (167 x 228 x 341)	7.0 x 8.7 x 12.3 (177 x 220 x 312)	7.4 x 9.4 x 13.4 (189 x 239 x 341)	11.4 x 10.9 x 13.0 (291 x 278 x 331)	4.0 x 7.1 x 2.6 (101 x 181 x 67)
	PPS	PTFE	PTFE	PTFE	PTFE	
	PTFE-coated	PTFE-coated	PTFE-coated	PTFE-coated	PTFE-coated	
	FFPM	FFPM	FFPM	FFPM	FFPM	
	Order no. 007006					
	Order no. 112432					
						Order no. 307757 (2 m) Order no. 307758 (5 m) Order no. 323829 (2 m)
	UST 800	UST 800	UST 800	UST 800	UST 800	
	Order no. 057953	Order no. 057953	Order no. 057953	Order no. 057953	Order no. 057953	
	Order no. 057954	Order no. 057954	Order no. 057954	Order no. 057954	Order no. 057954	

TECHNICAL DATA

	LABOPORT® N 820 G	LABOPORT® N 840 G	
<b>APPLICATION</b>	<b>Rotary evaporation</b>	X	X
	<b>Distillation</b>		
	<b>Degassing</b>	X	
	<b>Filtration</b>		X
	<b>SPE</b>		X
	<b>Fluid aspiration</b>	X	
	<b>Metering/Transferring liquids</b>		
	<b>Gel drying</b>	X	
	<b>Centrifugal concentration</b>		X
	<b>Vacuum oven</b>	X	X
	<b>Multi-user vacuum systems</b>		
<b>TECHNICAL DATA</b>	<b>Flow rate at atm. pressure – l/min (m³/h)</b>	20 (1.2)	34 (2.04)
	<b>Ultimate vacuum – torr (mbar abs.)</b>	4.5 (6)	4.5 (6)
	<b>Operating pressure – psig (bar)</b>	1.45 (0.1)	1.45 (0.1)
	<b>Connectors for tube – in.</b>	ID 3/8	ID 3/8
	<b>Permissible media and ambient temperature</b>	5 to 40 °C (41 to 104 °F)	5 to 40 °C (41 to 104 °F)
	<b>Weight – lbs. (kg)</b>	19.4 (8.8)	24.9 (11.3)
	<b>Dimensions W x H x D – in. (mm)</b>	6.4 x 8.7 x 10.2 (163 x 220 x 259)	7.0 x 9.4 x 11.4 (177 x 240 x 289)
<b>MATERIAL</b>	<b>Pump head</b>	PTFE	PTFE
	<b>Diaphragm</b>	PTFE-coated	PTFE-coated
	<b>Valves</b>	FFPM	FFPM

		LABOPORT® SR 820 G	LABOPORT® SH 820 G	LABOPORT® SR 840 G	LABOPORT® SH 840 G
APPLICATION	Filtration	x		x	
	Vacuum Oven	x		x	
	Degassing			x	
	Fluid aspiration	x			
	Distillation		x		x
	Rotary evaporation		x		x
	Centrifugal concentration	x		x	
TECHNICAL DATA	Flow rate (m³/h) at atm. pressure	1.2		2.04	
	Ultimate vacuum (mbar abs.)	6			
	Operating pressure (bar)	0.1			
	Hose connections (mm)	ID 9.5–8, PVDF			
	Permissible media and ambient temperature	+5 ... +40 °C			
	Integrated gas ballast valve	Yes			
	Integrated rotational speed control	Yes			
	Weight (kg)	10.7	11.7	13.1	14.1
	Dimensions W x H x D (mm)	282 x 234 x 260	323 x 416 x 260	299 x 250 x 274	340 x 416 x 274
MATERIAL	Pump head	PTFE			
	Diaphragm	PTFE-coated			
	Valves	FFPM			
ACCESSORIES	Separator flask	Order No. 047729			
	High performance condenser with pressure relief valve	-	Order No. 114855	-	Order No. 114855
	Hose connector with O-ring (FPM)	Order No. 323609			
	Hose connector PP (for hose ID10)	Order No. 026237			
	Screw connection cap red, GL18 (for hose connector ID 026237)	Order No. 025980			
	Hose connector PP (for hose ID8)	Order No. 025981			
	Screw connection cap red, GL14 (for hose connector ID 025981)	Order No. 025982			
	Key for hose connector	Order No. 316279			
	Connection cable (for combination with VC 900) 2 m	Order No. 323829			
	Connecting cable (for combination with VC 900) 5 m	Order No. 323830			
	Hose-BGR for Separator flask (1x for SH 840 G)	Order No. 323095			
	Hose BGR for high performance condenser (1x for SH 840 G)	Order No. 317157			
	Hose connector Y-piece - ID10	Order No. 026432			



TECHNICAL DATA

	SC 920 G	LABOPORT® SC 820	LABOPORT® SC 840	
<b>APPLICATION</b>	<b>Rotary evaporation</b>	x	x	x
	<b>Distillation</b>	x	x	x
	<b>Degassing</b>			
	<b>Filtration</b>			
	<b>SPE</b>			
	<b>Fluid aspiration</b>			
	<b>Metering/Transferring liquids</b>			
	<b>Gel drying</b>			
	<b>Centrifugal concentration</b>			
	<b>Vacuum oven</b>			
	<b>Multi-user vacuum systems</b>			
	<b>TECHNICAL DATA</b>	<b>Flow rate at atm. pressure – l/min (m³/h)</b>	21 (1.26)	20 (1.2)
<b>Ultimate vacuum – torr (mbar abs.)</b>		1.5 (2)	6 (8)	6 (8)
<b>Operating pressure – psig (bar)</b>			14.5 (1)	14.5 (1)
<b>Connectors for tube – in.</b>		pneumatic: ID 3/8 coolants: ID 5/16 inert gas: ID 1/4	pneumatic: ID 3/8 coolants: ID 5/16	pneumatic: ID 3/8 coolants: ID 5/16
<b>Permissible media and ambient temperature</b>		5 to 40 °C (41 to 104 °F)	5 to 40 °C (41 to 104 °F)	5 to 40 °C (41 to 104 °F)
<b>Weight – lbs. (kg)</b>		33.5 (15.2)	35.3 (16.0)	42.5 (19.3)
<b>Dimensions W x H x D – in. (mm)</b>	14.4 x 16.6 x 11.6 (366 x 423 x 294)	11.4 x 19.9 x 15.6 (289 x 506 x 397)	11.4 x 19.9 x 16.4 (289 x 506 x 417)	
<b>MATERIAL</b>	<b>Pump head</b>	PPS	PTFE	PTFE
	<b>Diaphragm</b>	PTFE-coated	PTFE-coated	PTFE-coated
	<b>Valves</b>	FFPM	FFPM	FFPM
<b>ACCESSORIES</b>	<b>Coolant valve – G 1/2, ID 5/6 in.</b>	Order no. 117121	Order no. 045075	Order no. 045075
	<b>Column fixture</b>	for remote control Order no. 120132		
	<b>Wall fixture</b>	for remote control Order no. 120130		
	<b>Charging station</b>	Order no. 129478		

	RC 600	C 900
<b>APPLICATION</b>		
Rotary evaporation	x	x
<b>TECHNICAL DATA</b>		
Heating bath: Heating bath temperature	20 to 180 °C (68 to 356 °F)	
Working temperature range		-10 to 40 °C (14 to 104 °F)
Coolant supply parameters (condenser):		
- Permissible pressure – psig (bar)	43.5 (3)	
- Permissible temperature	-15 to 20 °C (5 to 68 °F)	
- Coolant-coated surface – cm <sup>2</sup>	1230	
Cooling capacity – W		250
Parameters of evaporation flask:		
- Size of evaporation flask – ml	50 – 3000	
- Rotational speed of evaporation flask – l/min	25 – 280	
- Length of stroke – mm	150	
- Lifting speed – mm/s	38	
Temperature stability		± 0.5 °C
Filling volume – l		1.7 – 2.6
Cooling agent		R134a
Temperature control		PID temperature control
Weight – lbs. (kg)	20.1 (9.1)	59.5 (27)
Dimensions W x H x D – in. (mm)		
- without glass (footprint)	17.0 x 18.3 x 17.8 (431 x 464 x 453)	9.2 x 20.5 x 15.7 (235 x 520 x 400)
- with glass	19.2 x 32.4 x 17.8 (487 x 823 x 453)	-
<b>ACCESSORIES</b>		
Protective cover heating bath	Order no. 127204	
Refill valve	Order no. 300639	
Coolant valve		
Vacuum seal	Order no. 113046	
Vapor tube NS 24/400	Order no. 128762	
Integrated vapor tube/foam break	Order no. 302145	
Foam break NS 24/40	Order no. 301115	
Retort stand mount		
Column-mount bracket	Order no. 306221	
Dry ice cold finger	Order no. 301696	
Recirculating condenser	Order no. 128160	

	SIMDOS® 02	SIMDOS® 10	LIQUIPORT® NF 100	LIQUIPORT® NF 300	
<b>APPLICATION</b>	Rotary evaporation				
	Distillation				
	Degassing				
	Filtration				
	SPE				
	Fluid aspiration				
	Metering/Transferring liquids	x	x	x	x
	Gel drying				
	Centrifugal concentration				
	Vacuum oven				
	Multi-user vacuum systems				
<b>TECHNICAL DATA</b>	Flow rate with water at 20 °C and zero pressure head – ml/min	0.03 – 20	1 – 100		
	Flow rate with water at 20 °C and zero pressure head – l/min			0.2 – 1.3	0.5 – 3.0
	Operating pressure – psig (bar)	85 (6)	85 (6)	15 (1) [58 (4) for LIQUIPORT® NF 1.100]	15 (1) [58 (4) for LIQUIPORT® NF 1.300]
	Suction head – ft. water (mWg)	6.6 (2)	9.8 (3)	9.8 (3)	9.8 (3)
	Connectors for tube – in. (mm)	ID 1/16, OD 1/8	ID 1/8, OD 1/4	ID 5/16	ID 15/32
	Permissible media and ambient temperature	Ambient temp.: 5 to 40 °C (40 to 104 °F)	Ambient temp.: 5 to 40 °C (40 to 104 °F)	Ambient temp.: 5 to 40 °C (40 to 104 °F)	Ambient temp.: 5 to 40 °C (40 to 104 °F)
		Media temp.: 5 to 80 °C (40 to 176 °F)	Media temp.: 5 to 80 °C (40 to 176 °F)	Media temp.: 5 to 80 °C (40 to 176 °F)	Media temp.: 5 to 80 °C (40 to 176 °F)
Weight – lbs. (kg)	2.0 (0.9)	2.0 (0.9)	2.2 (1.0)	3.3 (1.5)	
Dimensions W x H x D – in. (mm)	3.7 x 5.7 x 5.9 (93 x 144 x 150)	3.7 x 5.7 x 5.9 (93 x 144 x 150)	3.9 x 7.0 x 5.1 (99 x 177 x 130)	4.1 x 7.4 x 6.3 (104 x 188 x 160)	
<b>MATERIAL</b>	Pump head	PP, PVDF, PTFE or stainless steel	PP, PVDF, PTFE or stainless steel	PP, PVDF or PTFE	PP, PVDF or PTFE
	Diaphragm	FFKM or PTFE-coated	PTFE-coated	PTFE-coated	PTFE-coated
	Valves	FFKM	FFKM	FFKM	FFKM
<b>ACCESSORIES</b>	Column fixture	Order no. 160474	Order no. 160474	Order no. 160474	Order no. 160474
	Wall fixture	Order no. 160473	Order no. 160473	Order no. 160473	Order no. 160473
	Foot switch for version RC (RC = flow rate can be set both manually and via an external control device)	Order no. 155872	Order no. 155872	Order no. 155872	Order no. 155872
	In-line filters	FS 60 T PVDF Mesh opening 70 µm Order no. 165210 FS 60 X PEEK Mesh opening 35 µm Order no. 323625	FS 25 T PVDF Mesh opening 70 µm Order no. 165211 FS 25 X PEEK Mesh opening 35 µm Order no. 165213		

## ACCESSORIES



Column fixture



Wall fixture



Foot switch



In-line filters FS 60



In-line filters FS 25





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